

# **Notice of References Cited**

Application/Control No.

09/820,176

Applicant(s)/Patent Under  
Reexamination  
VERMEIRE ET AL.

Examiner

Farhood Moslehi

Art Unit

2126

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## **NON-PATENT DOCUMENTS**

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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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